

4/ Authorization

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Atty. Docket

JOACHIM H. SCHOBET ET AL

AT 010007

Serial No.

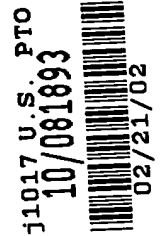
Group Art Unit

Filed: CONCURRENTLY

Ex.

Title: SEMICONDUCTOR WAFER WITH PROCESS CONTROL MODULES

Commissioner for Patents
Washington, D.C. 20231



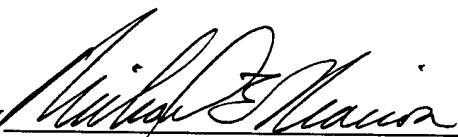
AUTHORIZATION PURSUANT TO 37 CFR §1.136(a)(3)
AND TO CHARGE DEPOSIT ACCOUNT

Sir:

The Commissioner is hereby requested and authorized to treat any concurrent or future reply in this application requiring a petition for extension of time for its timely submission, as incorporating a petition for extension of time for the appropriate length of time.

Please charge any additional fees which may now or in the future be required in this application, including extension of time fees, but excluding the issue fee unless explicitly requested to do so, and credit any overpayment, to Deposit Account No. 14-1270.

Respectfully submitted,

By 
Michael E. Marion, Reg. 32,266
Attorney
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